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Attorney Docket 0524-0136.01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In Re Application of   |  |
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| in the rippinoution of   | I hereby certify that this correspondence is being   |
| Tomotaka Yokoyama et al  | deposited with the United States Postal Service as first class mail in an envelope addressed to: |
| Serial No.: 10/761,771   | Commissioner for Patents,<br>P.O. Box 1450, Alexandria, VA 22313-1450 on                         |
| Filed: January 20, 2004 )  | March 8, 2005 (Date of Deposit)  |
| For: Management Technique Of Friction ) Coefficient Based On Surface Roughness Substrate For An Information Recording) Medium, Information Recording Medium And Manufacturing Method Thereof ) | Thannollallace 3/8/05  |
| Art Unit: 1773 )   |  |
| Examiner: Leszek B. Kiliman )  |  |
| Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450   |  |
| 1110/mining, V/1 22313-1730  |  |

## **RESPONSE TO OFFICE ACTION AND AMENDMENT (A)**

Sir:

Applicants have the following response to the Office Action of September 9, 2004.